#2 PRIORITY
2.26-01
Restores

35.G2732

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: Unassigned

February 20, 2001

MASATO MURAKI, ET AL.

Off Group Art Unit: 2881

Application No.: 09/708,590

Filed: November 9, 2000

For: CORRECTING METHOD FOR

CORRECTING EXPOSURE DATA:
USED FOR A CHARGED PARTICLE)
BEAM EXPOSURE SYSTEM:

Commissioner for Patents Washington, D.C. 20231

CLAIM FOR PRIORITY

Sir:

Applicants hereby claim priority under the

International Convention and all rights to which they are
entitled under 35 U.S.C. § 119 based upon the following Japanese
Priority Application:

11-353484, filed December 13, 1999.

A certified copy of the priority document is enclosed.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

Attorney for Applicants Registration No. 33,326

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